

## Erratum: Multiple Bifurcation Types and the Linear Dynamics of Ion Sputtered Surfaces [Phys. Rev. Lett. 101, 246102 (2008)]

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The equation of the line in Fig. 3(c) of our Letter should be  $5.7 \times 10^{-5} (19^\circ - \theta)$  and not  $5.7 \times 10^{-7} (19^\circ - \theta)$ . No changes need to be made to the text, and this correction does not affect the conclusions of the work.

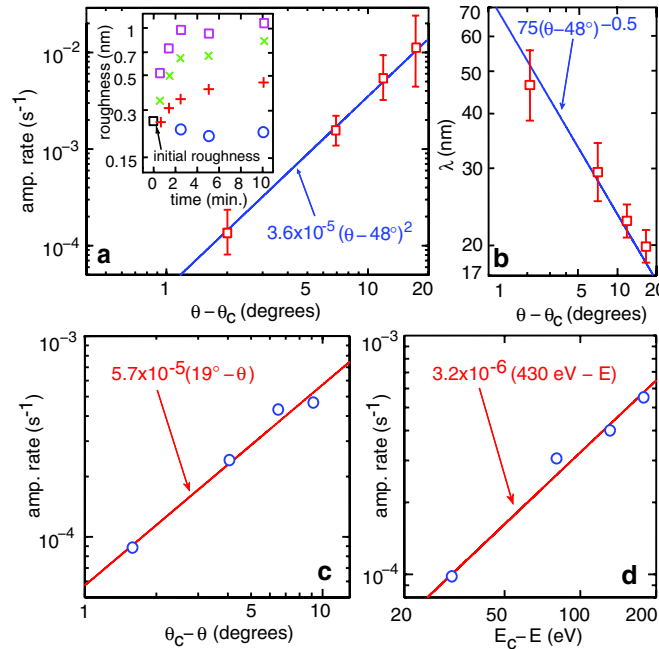


FIG. 3 (color online). Behavior near bifurcation points for (a),(b) high- $\theta$  and (c),(d) low- $\theta$  bifurcations. (a) Amplification rate versus misorientation for high- $\theta$  bifurcation. Inset: Pattern amplitude (reckoned as rms surface roughness) versus time. Squares:  $65^\circ$ ;  $\times$ :  $60^\circ$ ; +:  $55^\circ$ ; circles:  $50^\circ$ . (b) Wavelength versus misorientation for high- $\theta$  bifurcation. (c) Amplification rate versus misorientation for low- $\theta$  bifurcation. (d) Amplification rate versus  $E$  at  $\theta = 10^\circ$ . In (a)–(c),  $E = 250$  eV.